

In re Application of

Ryo TAKAI et al.

Appln. No.: 10/073,593

Filed: February 12, 2002

For: EXPOSURE APPARATUS INCLUDING  
INTERFEROMETER SYSTEM

Docket No. 00862.022516

Examiner: M. Lyons

Group Art Unit: 2877



Date: October 16, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment and a Request for Approval of Drawings Changed in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	37	MINUS	25	12	x \$ 9 \$18	\$ 216.00
INDEP. CLAIMS	7	MINUS	5	2	x \$43 \$86	\$ 172.00
Fee for Multiple Dependent claims \$145/\$290						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ 388.00

°Verified Statement claiming small entity status is enclosed, if not filed previously.

A check in the amount of \$388.00 is enclosed.

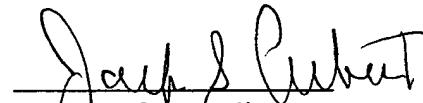
Charge \$\_\_\_\_ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.

RECEIVED  
OCT 23 2003  
TECHNOLOGY CENTER 2800

2877  
\$1

- Any prior general authorization to charge an issue fee under 37 C.F.R. § 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. §§ 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- A check in the amount of \$\_\_\_\_ to cover the Extension fee for response within \_\_\_\_ months is enclosed.
- A check in the amount of \$\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.
- Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants  
Jack S. Cubert  
Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

JSC\lp

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00862.022516.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ryo TAKAI et al.

Application No.: 10/073,593

Filed: February 12, 2002

For: EXPOSURE APPARATUS INCLUDING  
INTERFEROMETER SYSTEM

)  
: Examiner: M. Lyons  
)  
: Group Art Unit: 2877  
)  
: Confirmation No. 4328  
)  
:  
) October 16, 2003  
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated July 16, 2003, please amend the above-identified application as follows:

10/21/2003 ZJUHAR1 00000117 10073593

01 FC:1202  
02 FC:1201

216.00 OP  
172.00 OP